

Notice of References Cited	Application/Control No. 10/792,322	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Li Liu	Art Unit 2613	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0142978	07-2003	Lee et al.	398/34
*	B	US-6,847,758	01-2005	Watanabe, Shigeki	385/27
*	C	US-2001/0004290	06-2001	Lee et al.	359/124
*	D	US-2002/0196491	12-2002	Deng et al.	359/124
*	E	US-2003/0206740	11-2003	Lee et al.	398/79
*	F	US-2005/0163503	07-2005	Lee et al.	398/019
*	G	US-2004/0234195	11-2004	Pohjola et al.	385/024
*	H	US-2003/0058500	03-2003	Sugawara, Mitsuru	359/135
*	I	US-5,559,624	09-1996	Darcie et al.	398/72
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	H.D. Kim: "A Low-Cost WDM Source with and ASE Injected Fabry-Perot Semiconductor Laser", IEEE Photonics Technology Letters, Vol. 12, No. 8, August 2000, page 1067-1069
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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